

Docket No.: 1514.1030

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Serial No. 10/734,162

Group Art Unit: 2815

Confirmation No. 2087

Filed: December 15, 2003

Examiner: Landau, Matthew C.

For: THIN FILM TRANSISTOR WITH LDD/OFFSET STRUCTURE

**LETTER TO THE EXAMINER REQUESTING
APPROVAL OF THE CHANGES TO THE DRAWINGS**

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the Examiner having jurisdiction over the subject application approve the amendments to the drawings, on the attached copy of Figure 6.

A Letter Submitting Drawings is filed concurrently herewith, in which a clean copy of Figure 6 as amended is provided.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: 5/1/07

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